


<b>Search Notes</b>  	<b>Application/Control No.</b>  10645892	<b>Applicant(s)/Patent Under Reexamination</b>  BEDNAREK, MICHAEL C.
	<b>Examiner</b>  Michael Peffley	<b>Art Unit</b>  3739

SEARCHED			
Class	Subclass	Date	Examiner
606	41,48-50	1/21/09	/mp/
607	101-105	1/21/09	/mp/
update	above	9/16/09	/mp/
update	above	1/6/10	/mp/
update	above	4/29/2010	/mp/

SEARCH NOTES		
Search Notes	Date	Examiner

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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